

APR 18 2008

Appl. No. 10/743,985  
Amdt. dated 04/18/2008  
Response to Office Action of 02/26/2008

Attorney Docket No.: N1085-00188  
[TSMC 2003-0219]

/L.S./ 06/02/2008

OK to ENTER

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of: **Shui-Ming Chang**

Examiner: **Laura M. Schillinger**

Serial No.: **10/743,985**

Group Art Unit: **2813**

Filed: **12/22/2003**

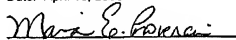
Confirmation No.: **9060**

**For: BODY CONTACT FORMATION IN PARTIALLY DEPLETED SILICON ON INSULATOR DEVICE**

**CERTIFICATE OF MAILING/FACSIMILE TRANSMISSION PURSUANT TO 37 C.F.R. §1.8**

I hereby certify that this correspondence (and anything referred to as being transmitted herewith) is being facsimile transmitted to the United States Patent and Trademark Office (Fax No. 571-273-8300) on the date shown below.

Date: April 18, 2008

  
Maria E. Provencio

Examiner Laura M. Schillinger  
Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**RESPONSE TO OFFICE ACTION DATED FEBRUARY 26, 2008  
REQUEST FOR RECONSIDERATION**

Commissioner:

Responsive to the Final Office action dated February 26, 2008, please re-examine and reconsider the subject patent application according to the remarks provided.

**No claim amendments** are filed in this paper.

**Remarks/Arguments** begin on page 2 of this paper.